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on June 27, 2001 in an envelope as "Express Mail Post Office to Addressee" service under 37, CFR §1.10, Mailing Label Number EL896842038US, addressed to the Assistant Commissioner for Patents,

Washington, DC 20231.

Kay Harlow

Attorney Docket No. LAM2P257

First Named Inventor: Francis Ko



UTILITY PATENT APPLICATION TRANSMITTAL (37 CFR § 1.53(b))

Assistant Commissioner for Patents
Box Patent Application
Washington, DC 20231

Duplicate for fee processing

Sir: This is a request for filing a patent application under 37 CFR § 1.53(b) in the name of inventors: Francis Ko, Richard Chen, and Charlie Lee

APPARATUS AND METHOD FOR ARGON PLASMA INDUCED ULTRAVIOLET LIGHT CURING STEP FOR INCREASING SILICON-CONTAINING PHOTORESIST SELECTIVITY

Application Elements:

	25 Pages of Specification, Claims and Abstract
\boxtimes	05 Sheets of Drawings (Informal)
\boxtimes	02 Pages Combined Declaration and Power of Attorney

Accompanying Application Parts:

1		Assignment and Assignment Recordation Cover Sheet (recording fee of \$40.00 enclosed)
		37 CFR 3.73(b) Statement by Assignee
		Information Disclosure Statement with Form PTO-1449
		Copies of IDS Citations
		Preliminary Amendment
	\boxtimes	Return Receipt Postcard
	\boxtimes	Request and Certification Under 35 U.S.C. 122(b)(2)(B)(i)

Fee Calculation (37 CFR § 1.16)

Other:

	(Col. 1)	(Col. 2)	SMALL ENTITY	OR	LARGE ENTITY
	NO. FILED	NO. EXTRA	RATE FEE		RATE FEE
BASIC FEE			\$355 \$	OR	\$710 \$710.00
TOTAL CLAIMS	_3620 =	16	x09= \$	OR	x18 = \$288.00
·INDEP CLAIMS	<u>05</u> -03 =	02	x40 = \$	OR	x80 = \$160.00
[] Multiple Depende	nt Claim Preser	ited	\$135 = \$	OR	\$270 = \$
* If the difference in	Col. 1 is less		Total \$	OR	Total \$1,158.00
than zero, enter "0" i	n Col. 2.				

\boxtimes	Check No. <u>5496</u> in the amount of \$ <u>1,198.00</u> is enclosed.
	The Commissioner is authorized to charge any fees beyond the amount enclosed which may be ired, or to credit any overpayment, to Deposit Account No. 50-0805 (Order No. <u>LAM2P257</u>).
Requ	Applicant is entitled to small entity status.
Gen	eral Authorization for Petition for Extension of Time (37 CFR §1.136)
	Applicant hereby makes and generally authorizes any Petitions for Extensions of Time as may be led for any subsequent filings. The Commissioner is also authorized to charge any extension fees under EFR §1.17 as may be needed to Deposit Account No. 50-0805 (Order No. <u>LAM2P257</u>).
\boxtimes	Please send correspondence to the following address:
	Michael L. Gencarella
	MARTINE & PENILLA, LLP
, D	710 Lakeway Drive, Suite 170
III - m	Sunnyvale, CA 94085
	Customer Number 25920
T	Tel (408) 749-6900
	Fax (408) 749-6901
	e: June 27, 2001 Michael L. Gencarella, Esq. Registration No. 44,703
indi Indi	







IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of)) Examiner: Unassigned					
Francis Ko et al.) Art Unit: Unassigned					
Application No. [To be assigned]))) Docket No. LAM2P257					
Filed: June 27, 2001 For: APPARATUS AND METHOD FOR ARGON PLASMA INDUCED ULTRAVIOL LIGHT CURING STEP FOR INCREASING SILICON-CONTAINING PHOTORESIST) Date: June 27, 2001 DLET) G)					
SELECTIVITY))					
REQUEST AND CERTIF Assistant Commissioner for Patents Washington, D.C. 20231 Sir: I hereby certify that the invention dis	CERTIFICATE OF EXPRESS MAILING I hereby certify that this correspondence is being deposited with the United States Posta Service on June 27, 2001 in an envelope as "Express Mail Post Office to Addressee" service under 37 CFR § 1.10, Mailing Label Number EL896842038US, addressed to the Commissioner for Patents, Washington, DC 20231. Signed: Kay Harlow REQUEST AND CERTIFICATION UNDER 35 U.S.C. § 122(b)(2)(B)(i) ssistant Commissioner for Patents Vashington, D.C. 20231					
I hereby certify that the invention dis	sclosed in the attached application has not and will not be the					
subject of an application filed in another cou	untry, or under a multilateral agreement, that requires					
publication at eighteen months after filing.	I hereby request that the attached application not be published					
under 35 U.S.C. § 122(b).						
	Respectfully submitted, MARTINE & PENILLA, LLP					
	Milastemanell					
	Michael L. Gencarella, Esq.					

Reg. No. 44,703

710 Lakeway Drive, Suite 170 Sunnyvale, CA 94085 (408) 749-6900

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